



IFW  
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of

Hiromi OTOMA

Group Art Unit: 2821

Application No.: 10/826,354

Examiner: C. TRAN

Filed: April 19, 2004

Docket No.: 119498

For: SURFACE EMITTING SEMICONDUCTOR LASER AND COMMUNICATION  
SYSTEM USING THE SAME

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the October 18, 2005 Office Action, please consider the following:

**Amendments to the Drawings** include attached replacement sheets; and

**Remarks.**

02/23/2006 BABRAHA1 00000037 10826354

01 FC:1251

120.00-0P